

Electronic Patent Application Fee Transmittal

Application Number:	10814482			
Filing Date:	31-Mar-2004			
Title of Invention:	Method for fabricating strained silicon-on-insulator structures and strained silicon-on insulator structures formed thereby			
First Named Inventor/Applicant Name:	Toshiharu Furukawa			
Filer:	William R. Allen/Angela Malik			
Attorney Docket Number:	ROC920030399US1			

Filed as Large Entity

Utility Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Notice of appeal	1401	1	500	500
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Post-Allowance-and-Post-Issuance:

Extension-of-Time:

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				500